

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Emmanuel Hadji et al.

Serial No.: 09/673,005

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Title: PROCESS FOR THE FORMATION OF A
SILICON LAYER ON A SUPPORT FOR
OPTICAL PURPOSES, AND USE IN THE
PROCESS TO MAKE OPTICAL COMPONENTS

Docket No.: 33019

1702

1762 FF

C.7

3/15/01

INFORMATION DISCLOSURE STATEMENT

Asst. Commissioner for Patents
ATTN: Box PCT
Washington, D.C. 20231

Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,
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RECEIVED

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November 20, 2000

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on the date indicated below.

Jeffrey J. Sopko
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for Applicant(s)
11/20/00
Date Signature of Attorney